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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Mail Stop: ISSUE FEE**
Yoshihiro GUNJI et al. : **Confirmation No. 1256**
Serial No. 09/917,732 : **Group Art Unit 1763**
Filed July 31, 2001 : **Examiner Sylvia MacArthur**

SUBSTRATE HOLDING APPARATUS AND
SUBSTRATE POLISHING APPARATUS

AMENDMENT UNDER 37 CFR 1.312

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the allowance of the above-referenced U.S. patent application, kindly amend the application as follows:

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0875